

DPS2005 Program

Start	End	
Sunday, 27 Nov.		
Convention Lobby		
1700	2000	Registration
1800	2000	Welcome Reception

Monday, 28 Nov.		
Ballroom 1 (2F)		
Session 1: Opening Session		
0830	0840	Opening H. Sugai
0840	0915	1-01 Keynote U-In. Chung
Session 2: Etching		
0915	0950	2-01 Invited S. K. Lee
0950	1010	2-02 Contributed S.C.Park
1010	1025	Break
1025	1100	2-03 Invited I. Jang
1100	1120	2-04 Contributed A. Ando
1120	1140	2-05 Contributed J. Abe
1140	1200	2-06 Contributed S. Sakamori
1200	1310	Lunch
Session 3: Plasma		
1310	1345	3-01 Invited J.P. Booth
1345	1420	3-02 Invited M. Kushner
1420	1440	3-03 Contributed Y.Nojiri
1440	1515	3-04 Invited E. Stamate
1515	1530	Break
Session 4: Plasma Damage		
1530	1605	4-01 Invited P. Aum
1605	1625	4-02 Contributed K. Tokashiki
1625	1645	4-03 Contributed H. Kokura
Session 5: Poster Session 1		
1645	1835	Poster (Convention Lobby)

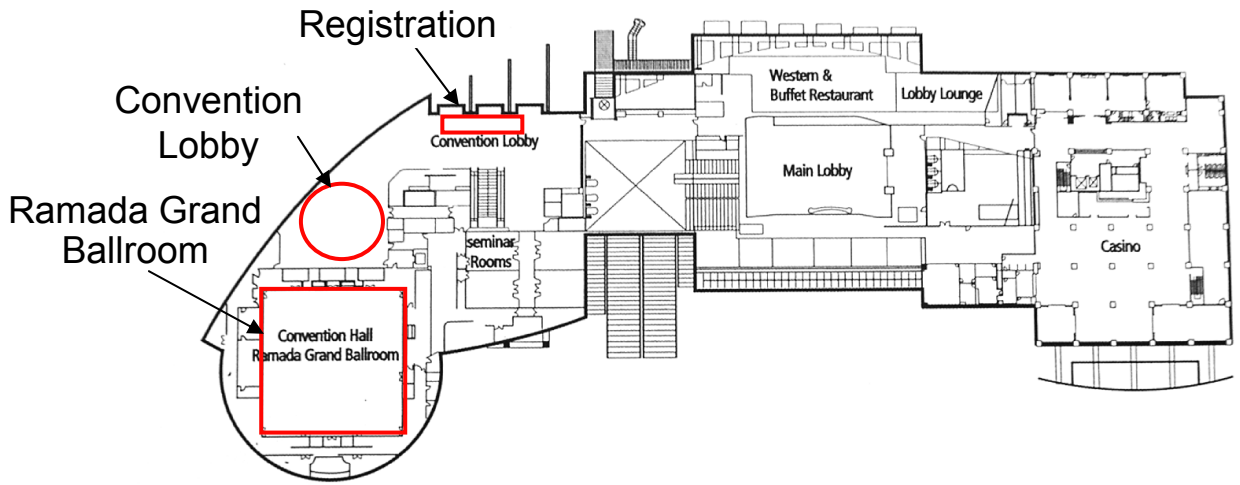
Tuesday, 29 Nov.		
Ballroom 1 (2F)		
Session 6: Low-k / Integration Arranged Session		
0830	0855	6-01 Invited H. Hayashi
0855	0920	6-02 Invited K. Yonekura
0920	0940	6-03 Contributed H. Ohtake
0940	1000	6-04 Contributed M.Nagase
1000	1020	6-05 Contributed S. Uno
1020	1035	Break
1035	1100	6-06 Invited K. Komura
1100	1120	6-07 Contributed K. Tomioka
1120	1145	6-08 Invited K-K. Choi
1145	1205	6-09 Contributed M. Shiratani
1205	1330	Lunch
Session 7: Diagnostics of Plasma / Surface		
1330	1405	7-01 Invited G. Cunge
1405	1440	7-02 Invited L. J. Overzet
1440	1455	Break
1455	1530	7-03 Invited R. McWilliams
1530	1550	7-04 Contributed S. Yajima
1550	1610	7-05 Contributed A. Kono
Session 10: Poster Session 2		
1610	1800	Poster (Convention Lobby)
1800	1815	Break
1815	1830	DPS 2004 Award Presentation
1830	2030	Banquet (Ballroom)

Wednesday, 30 Nov.		
Tamna Hall (8F)		
Session 11: High-k and Metal Gate Etching		
0830	0905	11-01 Invited W.J. Yoo
0905	0925	11-02 Contributed L. Hsu
0925	0945	11-03 Contributed W. S. Hwang
0945	1005	11-04 Contributed M. Demand
1005	1020	Break
Session 12: New Dry Process Concept		
1020	1055	12-01 Invited A. Schwabedissen
1055	1115	12-02 Contributed T. Okada
1115	1125	Break
Session 13: MEMS		
1125	1145	13-01 Contributed E. Sakata
1145	1205	13-02 Contributed S. Shin
1205	1225	13-03 Contributed C.-S. Jeon
1225	1330	Lunch
Session 14: Nano / Bio		
1330	1405	14-01 Invited J.-M. Ting
1405	1440	14-02 Invited Y. Baba
1440	1500	14-03 Contributed R. Ogawa
1500	1520	14-04 Contributed T. Y. Lee
1520	1540	14-05 Contributed H. Nagao
1540	1545	Closing C.-K. Choi

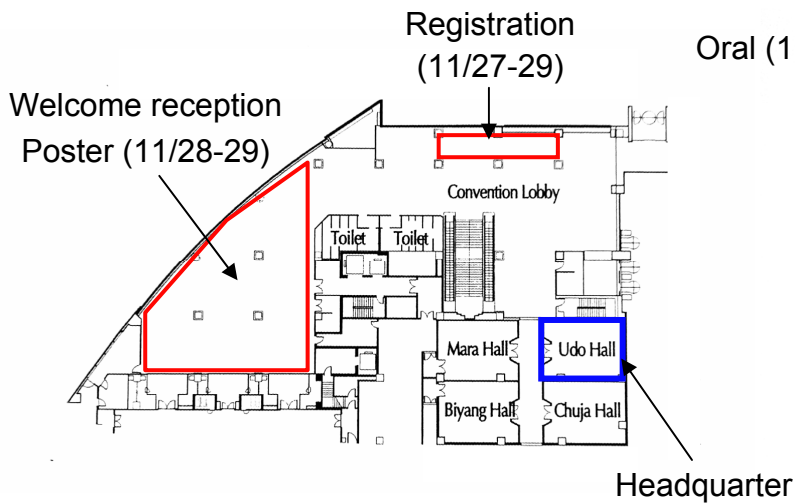
Tuesday, 29 Nov.				
Ballroom 2 (2F)				
Session 8: Flat Panel Arranged Session				
0920	0945	8-01	Invited	J. Jan
0945	1010	8-02	Invited	A.A. Howling
1010	1035	8-03	Invited	H. Kobayashi
1035	1055	8-04	Contributed	J. Y. Song
1055	1110			Break
1110	1135	8-05	Invited	S.-R. Hong
1135	1155	8-06	Contributed	H. H. Kim
1155	1220	8-07	Invited	M.-P. Hong
1220	1330			Lunch
Session 9: CVD				
1330	1350	9-01	Contributed	T. Murata
1350	1410	9-02	Contributed	T. Sakata
1410	1430	9-03	Contributed	K. Shitanaka
1430	1450	9-04	Contributed	K. W. Do
1450	1510	9-05	Contributed	M. Ishikawa

Ramada Plaza Jeju Hotel

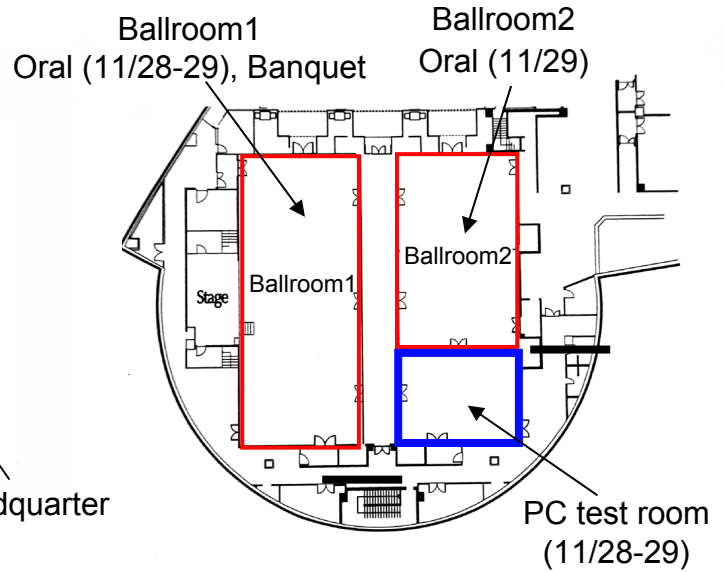
2nd Floor



Convention Lobby



Ramada Grand Ballroom



8th Floor

